

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:) Group Art Unit: 1765
T. Morikawa et al.) Examiner: Kin-Chan Chen
Application No. 10/775,932	I hereby certify that this document is being deposited with the United States Postal Service as first class mail
Filed: February 10, 2004	in an envelope addressed to: MAIL STOP AMENDMENT, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on January 31, 2006.
For: METHOD FOR MANUFACTURING SEMICONDUCTOR DEVICE) Roxanne M. Swartz

MAIL STOP AMENDMENT Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

RESPONSE TO OCTOBER 12, 2005 OFFICE ACTION

Dear Sir:

This Amendment is submitted in response to the Office Action mailed October 12, 2005.

Applicants respectfully request amendment of the patent application, and reconsideration and allowance of the pending claims.